

APR 26 2005

*Entered
4/28/05*

Amendment Under 37 C.F.R. § 1.116
Group Art Unit 2828, Expedited Procedure

03500.016650.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: H. Philogene
SHUJI AOKI ET AL.)
: Group Art Unit: 2828
Application No.: 10/648,490)
: Filed: August 27, 2003)
: For: METHOD AND APPARATUS FOR)
ADJUSTING CHARACTERISTICS)
OF MULTI ELECTRON SOURCE) April 26, 2005

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Office Action of January 26, 2005, please amend the
above identified application as follows.

I hereby certify that this correspondence is being facsimile transmitted
to the Patent and Trademark Office (Fax No. (703) 872-9306) on
April 26, 2005.

(Date of Transmission)

FRANK A. DELUCIA (REG. NO. 42,476)

(Name of Attorney for Applicant)

Signature

April 26, 2005

Date of Signature